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SERIAL NUMBER 10/690,318	FILING DATE 10/21/2003 RULE	CLASS 438	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. 8327/ETCH/SILICON/JB
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APPLICANTS

David Mui, Fremont, CA;

Wei Liu, San Jose, CA;
Hiroki Sasano, Sunnyvale, CA;

** CONTINUING DATA *****

None / EC

** FOREIGN APPLICATIONS *****

None / EC

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 01/21/2004

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged	CA	6	30	5
Examiner's Signature <i>Eric Chen</i>	Initials EC			

ADDRESS

44257
MOSER, PATTERSON & SHERIDAN, LLP
APPLIED MATERIALS, INC.
3040 POST OAK BOULEVARD, SUITE 1500
HOUSTON , TX
77056

TITLE

Method for controlling accuracy and repeatability of an etch process

FILING FEE RECEIVED 1122	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue)
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